

IRW

Attorney Docket No. 5649-1253

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Son et al.

Serial No.: 10/811,351

Filed: March 26, 2004

For: METHODS OF FORMING FERROELECTRIC CAPACITORS USING
SEPARATE POLISHING PROCESSES

Group Art Unit: 2891

Examiner: Yoon-ho Son

Confirmation No.: 1560

November 7, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

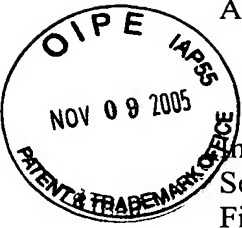
Sir:

Applicant provides the present Response to Restriction Requirement to address the issues raised in the Restriction Requirement dated October 7, 2005. Applicant respectfully requests entry of this Response and allowance of the application.

It is not believed that an extension of time and/or additional fee(s), including fees for additional claims, are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

Amendments to the Claims are reflected in the listing of claims, which begin on page 3 of this paper.

Remarks begin on page 7 of this paper.



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Page 2 of 7

In the Title:

Please amend the title in all occurrences as indicated below:

METHODS OF FORMING FERROELECTRIC CAPACITORS USING
SEPARATE POLISHING PROCESSES ~~AND FERROELECTRIC CAPACITORS SO~~
~~FORMED~~